

VIA EFS  
Patent  
Docket No. 514312000400  
Client Reference No. 04PCT23-US

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re Patent Application of:  
Takayuki TOSHIMA et al.

Application No.: 10/579,423

Confirmation No.: 1339

Filed: May 11, 2006

Art Unit: 1792

For: SUBSTRATE PROCESSING METHOD,  
SUBSTRATE PROCESSING APPARATUS  
AND COMPUTER-READABLE MEMORY  
MEDIUM

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Examiner: Ryan L. Coleman

**RESTRICTION REQUIREMENT RESPONSE**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

This is in response to the Restriction Requirement set forth in the Office Action dated September 16, 2009, for which a response is due on October 16, 2009. Accordingly, this response is timely filed.

There are no amendments to the specification, drawings, and claims.

A **Listing of the Claims** begins on page 2 of this paper.

**Remarks/Arguments** begin on page 10 of this paper.